

<b>Notice of References Cited</b>	Application/Control No. 10/783,316	Applicant(s)/Patent Under Reexamination RAJAGOPALAN ET AL.	
	Examiner Keath T. Chen	Art Unit 1709	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0076508	06-2002	Chiang et al.	427/569
*	B	US-2003/0017267	01-2003	Mukai et al.	427/255.28
*	C	US-6,511,923	01-2003	Wang et al.	438/783
*	D	US-2001/0035127	11-2001	METZNER et al.	118/715
*	E	US-6,261,374	07-2001	Bang et al.	118/726
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.